

**Search Notes**

Application/Control No.

10/727,597

Examiner

Jason M. Han

Applicant(s)/Patent under  
Reexamination

LEE, TA-YUAN

Art Unit

2875

**SEARCHED**

Class	Subclass	Date	Examiner
362	23-30	3/7/2006	JMH
362	84-85	3/7/2006	JMH
362	230-231	3/7/2006	JMH
362	236-237	3/7/2006	JMH
362	248	3/7/2006	JMH
362	251	3/7/2006	JMH
362	293	3/7/2006	JMH
362	616	3/9/2006	JMH
116	297	3/7/2006	JMH

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner
EAST (US-PGPUB) - See Interference Printout		3/7/2006	JMH

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
Search Update - EAST (US-PGPUB, USPAT, USOCR, EPO, JPO, DERWENT) - See Printout	3/7/2006	JMH